

PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
Name	Execution Date
University of Michigan	11/18/2010
RECEIVING PARTY DATA	
Name:	National Science Foundation
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Property Type	Number
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License to the United States Government

Invention Title: Methods for Embedding Glass into Silicon Wafers

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Patent or Application Serial No.: 12/581,695

Grant/Contract Numbers::NSF - EEC9986866.

Foreign Applications filed/intended in (countries): PCT - PCT/US2010/053221

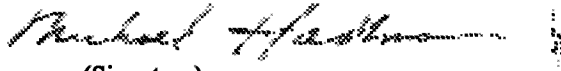
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Signed this 18th day of November, 2010.

By: Michael Hallman
(Name of Grantee/Contractor Official)


(Signature)

Title: Patent Administrator

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